

## EAST Search History

| Ref # | Hits   | Search Query                 | DBs  | Default Operator | Plurals | Time Stamp       |
|-------|--------|------------------------------|--|------------------|---------|------------------|
| L11   | 73863  | "non-metallic"               | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | OFF     | 2007/01/23 17:40 |
| L12   | 84385  | "backside"                   | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | OFF     | 2007/01/23 17:40 |
| L13   | 872    | l11 and l12                  | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | OFF     | 2007/01/23 17:40 |
| L14   | 101952 | "silicon carbide"            | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT                      | OR               | OFF     | 2007/01/23 17:40 |
| L15   | 65     | l13 and L14                  | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | OFF     | 2007/01/23 18:19 |
| L16   | 109    | "radiation absorption layer" | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT                      | OR               | OFF     | 2007/01/23 17:41 |
| L17   | 0      | l15 and L16                  | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | OFF     | 2007/01/23 17:41 |

## EAST Search History

|     |         |                   |  |    |     |                  |
|-----|---------|-------------------|--|----|-----|------------------|
| L18 | 84385   | "backside"        | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2007/01/23 18:19 |
| L19 | 3388    | "SiC Substrate"   | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2007/01/23 18:19 |
| L20 | 11      | l18 near l19      | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2007/01/23 18:40 |
| L21 | 2237658 | "substrate"       | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2007/01/23 18:40 |
| L22 | 18899   | "underlayer"      | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2007/01/23 18:40 |
| L23 | 1587    | l21 near l22      | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2007/01/23 18:40 |
| L24 | 102070  | "silicon carbide" | US-PGPUB;<br>USPAT;<br>USOCR;<br>FPRS;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2007/01/23 18:41 |